



Attorney Docket No. 54008.8009.US02  
P97-0041US3

05/23/03  
D.G.  
1140  
**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Raymon F. THOMPSON et al.

APPLICATION NO.: 09/575,551

FILED: MAY 22, 2000

FOR: **SEMICONDUCTOR PROCESSING SYSTEM WITH  
WAFER CONTAINER DOCKING AND LOADING  
STATION**

EXAMINER: James W. Keenan

ART UNIT: 3652

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MAY 08 2003

**GROUP 3600**

**AMENDMENT IN REQUEST FOR CONTINUING EXAMINATION  
FOLLOWING DECISION ON APPEAL**

**Introduction:**

A Decision on Appeal from the final rejection of claims 56, 57, 62, 64, and 65 was mailed February 26, 2003. The new and amended claims in the present Amendment have been prepared in view of the Decision on Appeal. A Request for Continuing Examination and filing fee accompany this Amendment.

**In the Claims:**

Please amend claims 56 and 65 and add new claims 66-72 as shown on the attached claim sheets.

**Certificate of Mailing**

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage in an envelope addressed to the Assistant Commissioner for Patents, Washington, DC 20231.

April 28, 2003  
Date of Deposit

Debbie Gilbert  
Debbie Gilbert